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Docket No. 1232-5336

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Seiya MIURA

Group Art Unit: 2851

Serial No.: 10/798,817

Examiner: Peter Kim

Filed: March 10, 2004

For: EXPOSURE APPARATUS, EXPOSURE METHOD, AND DEVICE
MANUFACTURING METHOD

AMENDMENT PURSUANT TO 37 C.F.R. §1.111

Mail Stop **Amendment**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Official Action dated September 7, 2005, Applicant respectfully requests reconsideration in view of the following amendments and remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.